

HF/2800

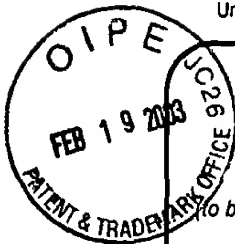
PTO/SB/21 (08-00)

Please type a plus sign (+) inside this box → ☐

Approved for use through 10/31/2002. OMB 0651-0031

U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.



# TRANSMITTAL FORM

(to be used for all correspondence after initial filing)

Application Number	09/632,425
Filing Date	August 4, 2000
First Named Inventor	Geiger, Fabrice
Group Art Unit	2829
Examiner Name	Lisa A. Kilday
Attorney Docket Number	A3024/T28300

Total Number of Pages in This Submission

## ENCLOSURES (check all that apply)

<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input checked="" type="checkbox"/> Amendment / Reply <input checked="" type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input type="checkbox"/> Information Disclosure Statement <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/ Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Assignment Papers (for an Application) <input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s)	<input type="checkbox"/> After Allowance Communication to Group <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input checked="" type="checkbox"/> Other Enclosure(s) (please identify below): Two Return Postcards
--	---	---

Remarks

The Commissioner is authorized to charge any additional fees to Deposit Account 20-1430.

## SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

Firm and Individual name	Townsend and Townsend and Crew LLP Chun-Pok Leung	Reg. No. 41,405
Signature		
Date	2-11-03	

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on this date:

February 11, 2003

Typed or printed name Andrea S. Beck

Signature

Date

2/11/03

Burden Hour Statement: This form is estimated to take 0.2 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.

PA 3283316 v1

RECEIVED  
FEB 21 2003  
TECHNOLOGY CENTER 2800

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Box AF  
Assistant Commissioner for Patents  
Washington, D.C. 20231

On February 11, 2003  
TOWNSEND and TOWNSEND and CREW LLP

By: [Signature]



AMENDMENT UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE -  
EXAMINING GROUP 2829

Attorney Docket No.: A3024/T28300  
TTC Ref. No.: 16301-028300

DO NOT ENTER  
LAK 3/2/03  
OK to enter  
4/24/03 LAK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Fabrice Geiger et al.

Application No.: 09/632,425

Filed: August 4, 2000

For: PROCESS FOR DEPOSITING A  
POROUS, LOW DIELECTRIC  
CONSTANT SILICON OXIDE FILM

Examiner: Lisa A. Kilday

AMENDMENT UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE EXAMINING  
GROUP 2829

Box AF  
Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Final Office Action mailed December 11, 2002, please amend this application as follows:

IN THE SPECIFICATION:

Page 17, TABLE 2, please change "500 Å/min" to --5500 Å/min--.

Page 17, please delete footnotes 1 and 2.

Page 17, lines 2-7, please amend the paragraph as follows:

From Table 2, if the underlayer is thermal oxide then the deposition rate is lower, the wet etch rate is significantly higher, the surface roughness worse, and the stress hysteresis, in a room temperature to 360°C heat cycle, is higher than an underlayer

RECEIVED  
FEB 21 2003  
TECHNOLOGY CENTER 2800